

09/540288

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,771,019 B1  
DATED : August 3, 2004  
INVENTOR(S) : Wu et al.

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 41.

Line 32, after "phosphor deposits" insert -- , said at least first and second phosphor deposits being formed from phosphors of different host materials --.

Column 43.

Line 30, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 61 delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Column 44.

Line 51, delete "a threshold voltage" and replace with -- the threshold voltage --.

Column 45.

Lines 3-4, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 64, after "dielectric layer" insert --, S is the dielectric strength of the dielectric layer --.

Column 49.

Line 30, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 56, delete "a thickness" and replace with -- the thickness --.

Line 59, after "dielectric layer" insert -- , S is the dielectric strength of the dielectric layer --.

09 / 540 288

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,771,019 B1  
DATED : August 3, 2004  
INVENTOR(S) : Wu et al.

Page 2 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 52.

Lines 12-13, delete "a threshold voltage" and replace with -- the threshold voltage --.  
Lines 29-30, delete "a threshold voltage adjustment layer selected" and replace with  
-- the threshold voltage adjustment layer being selected --.

Signed and Sealed this

Eighth Day of February, 2005



JON W. DUDAS  
*Director of the United States Patent and Trademark Office*